



(19)

(11) Publication number: **2002**

Generated Document.

PATENT ABSTRACTS OF JAPAN(21) Application number: **2001039441**(51) Intl. Cl.: **G02B 7/198**(22) Application date: **16.02.01**

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| (30) Priority: | (71) Applicant: HITACHI ELECTRONICS LTD |
| (43) Date of application publication: 28.08.02 | (72) Inventor: FUKAWA MASANORI SERIKAWA SHIGERU |
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**(54) MECHANISM FOR
ADJUSTING DISTANCE
AND ANGLE OF MIRROR**

(57) Abstract:

PROBLEM TO BE SOLVED: To provide a mechanism for adjusting the distance and the angle of a mirror by which the adjusting positional deviation of the mirror caused by vibration is prevented.

SOLUTION: This mechanism has a conical groove provided on a movable plate to which the mirror is attached and receiving the tip of one of three micrometer screws and a V-shaped groove provided on the movable plate and receiving the tip of the other one of three micrometer screws.

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